

CALIFORNIA INSTITUTE OF TECHNOLOGY MASSACHUSETTS INSTITUTE OF TECHNOLOGY

E980069	00	-D
DRWG NO.	RE	V.

SHEET OF

GID

# COMPONENT SPECIFICATION BEAM SPLITTER SUBSTRATE, COATED

APPROVALS: Helena Armandula	DATE 03-13-98	REV	DCN NO	BY	СНК	DCC	DATE
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APPROVED:							
DCC RELEASE:							

# **Applicable Documents**

LIGO-D960789-B-D Beam Splitter Substrate Substrate, Beam Splitter LIGO-E960100- B-D

## **Requirements**

TITLE

### **Physical Configuration**

Fabricate from		
LIGO-D960789-B-D		

Beam Splitter Substrate

### Surface 1 and 2

Coating to be centered at 1064 nm Angle of Incidence to be 45 degrees - Optimized for "P" polarization

**Coating Uniformity:** 

1nm rms - central 8 cm 15 nm p-v - over 20 cm Scatter: <15 ppm Absorption: <1 ppm

Zero surface electrical field

### **Surface Quality**

To comply with LIGO Component Specification E960093-A-D (Page 2): "Scratches and Point Defects" Coating to resist abrasion test per MIL-M-13508C

### **Surface 1: Beam Splitter Coating**

Transmission / Reflection: 50% +/-1%



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# Surface 2: AR Coating

Reflection:

< 100 ppm

# NOTE:

TITLE

Coating manufacturer to provide:

- 1. One (1 in.) witness plate from each coating run
- 2. Spectrophotometer graphs of Reflectance and Transmittance of HR coating
- 3. Spectrophotometer graph of Reflectance of AR coating